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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yvon Gris et al.
Serial No.: 09/988,233
Confirmation No.: 8198
Filed: November 19, 2001
For: METHOD OF DEPOSITION OF A SINGLE-CRYSTAL
SILICON REGION
Examiner: Matthew J. Song
Art Unit: 1765

CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)

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Christine A. Gardner

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action mailed January 24, 2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this amendment.

Remarks begin on page 6 of this amendment.